# NenoVision

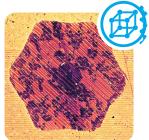
### Next level of imaging

# AFM-in-SEM LiteScope<sup>™</sup>

# **Unique applications**

LiteScope has a range of unique applications. It is a great choice for measurement applications where **simultaneous utilization of an SEM and an AFM** is either **completely indispensable** or **vastly superior to** the use of **separate** conventional **instruments**.

### **Application areas**



### **Material Science**

- 1D / 2D materials
- Steel & metal alloys
- Batteries
- Ceramics
- Polymers & Composites



### Nanostructures

- Modified surfaces FIB/GIS
- Quantum dots
- Nanostructured films
- Nano-patterning
- Nanowires



### Semiconductors

- Integrated circuits
- Solar cells
- MEMS / NEMS
- Failure analyses
- Dopant visualization
- Current leakage
  localization



### Life Science

- Cell biology
- Marine biology
- Protein technology

## Key technology benefits

# 1 Complex and correlative sample analysis

Unique CPEM technology enables **simultaneous acquisition of AFM and SEM channels** and their seamless **correlation into 3D** images.

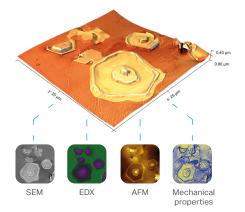
### 2 In-situ sample characterization

In-situ conditions inside the SEM ensure sample analysis at the **same time**, in the **same place** and under the **same conditions**.

### 3 Precise localization of the region of interest

Extremely precise and timesaving approach **uses SEM to navigate the AFM tip** to the region of interest, enabling its fast & easy localization.

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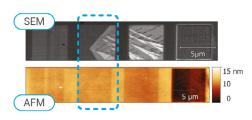


## **Complex analysis of 2D materials**

#### Analysis of molybdenum carbide

Complex correlative imaging of an identical spot on the Mo<sub>2</sub>C sample includes topography, EDX, conductivity and mechanical properties.

- CPEM: precise correlation of chosen AFM and SEM data
- SEM-EDX: fast nanostructure localization and elemental analysis
- AFM: topography, conductivity, mechanical properties



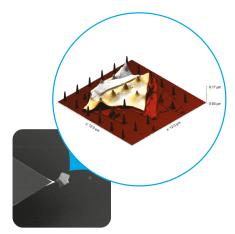
CPEM

## In-situ characterization of sensitive samples

#### Magnetic nanopatterning

In-situ AFM-in-SEM was necessary to selectively change the sample by Focused Ion Beam and immediately characterize magnetic properties of metastable  $Fe_{78}Ni_{22}$  thin films.

- In-situ conditions FIB-induced transformation of a sensitive sample had to be characterized by AFM and SEM in in-situ conditions.
- Immediate and precise ROI identification small structural change at the FIB induced interface had to be analyzed by AFM.



# Precise localization of the region of interest

#### WSe<sub>2</sub> flakes on silicon nanopillars

A certain shape of a WSe<sub>2</sub> flake monolayer over nanopillars creates a single-photon emitter.

- Fast ROI localization by SEM
- Difficult sample for AFM combination of 1D and 2D materials
- **CPEM:** correlation of topography with monolayer resolution (AFM) and material contrast (SEM)